

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of : **Confirmation No. 4423**
Tomohiro OKUMURA et al. : Docket No. 2001-1089A
Serial No. 09/918,823 : Group Art Unit 2821
Filed August 1, 2001 : Examiner T. Phan
PLASMA PROCESSING METHOD :
AND APPARATUS THEREOF :

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of May 21, 2003, a three month Extension of Time having been obtained, please consider the following remarks.

RECEIVED
DEC - 3 2003
TECHNOLOGY CENTER 2800